



LFK

LPD-100/CON/US
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: A. J. Flanigan
Robert A. Rauch)
: Group Art Unit: 3753
Application No.: 10/691,171)
: Confirmation NO.: 6526
Filed: October 22, 2003)
:
For: THERMAL INTERFACE WAFER)
AND METHOD OF MAKING :
AND USING SAME) August 15, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE COMMUNICATION

Sir:

Responsive to the Office Action mailed August 5, 2005,
and supplemental to Applicant's Amendment dated June 20, 2005,
Applicant has prepared and submits herewith a Terminal
Disclaimer. Entry of this Response and Terminal Disclaimer are
earnestly solicited.

Applicant's undersigned attorney may be reached at
telephone (860) 571-5001 or by facsimile at (860) 571-5028. All
correspondence should be directed to the address given below.

Respectfully submitted,

Steven Bauman
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